IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application Commissioner of Patents and Trademarks Washington, D.C. 20231

Re:

Inventor(s):

Manoocher Birang and Shijian Li,

Title:

CHEMICAL MECHANICAL POLISHING WITH FRICTION-BASED CONTROL

Transmitted herewith is the patent application identified above, including:

- X Specification, claims and abstract, totaling (14) pages.
- X Formal Drawings totaling (3) pages
- X Executed Declaration and Power of Attorney.

This application is a divisional application (and claims the benefit of priority under 35 USC 120) of U.S. Application Serial No. 09/562,801, filed on May 2, 2000, which claims priority to U.S. Provisional Application Serial No. 60/132,668 filed May 5, 1999. The disclosures of the priority applications are considered part of (and are incorporated by reference in) the disclosure of this

FEE CALCUI	ATION				
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	24	-20=	4	X \$18.00	\$ 72.00
Independent Claims	3	-3=	3	X \$84.00	\$
Basic Filing Fee \$750.00					\$750.00
TOTAL FEES					\$822.00

- XX The Commissioner is hereby authorized to charge \$822.00 to Deposit Account No. 50-1074
- XX The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- <u>XX</u> Please address all future correspondence to:

PATENT COUNSEL APPLIED MATERIALS, INC. Legal Affairs Department P.O. BOX 450A Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231.

xpress Mail Receipt No. EV321 388 283 US

Date of Deposit SEPTEMBER 17, 20

Signature / Signature

Respectfully submitted,

Robert W. Mulcahy Registration No. 25,436